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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.10/082,599
Filing Date February 22, 2002
Inventorship Craig M. Carpenter et al.
Assignee Micron Technology, Inc.
Group Art Unit 1763
Examiner Karla A. Moore
Attorney's Docket No. MI22-1941
Customer No. 021567
Title: Interfacial Structure for Semiconductor Substrate Processing Chambers
and Substrate Transfer Chambers and for Semiconductor Substrate
Processing Chambers and Accessory Attachments, and Semiconductor
Substrate Processor

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

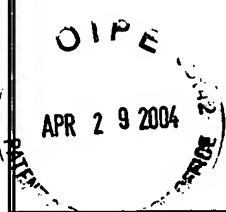
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are attached hereto. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a Request for Continued Examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 4/29/04

By: 
Mark S. Matkin, Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1941		SERIAL NO. 10/082,599	
<div style="text-align: center;">  </div> <div style="text-align: center;"> LIST OF ART CITED BY APPLICANT <small>(Use several sheets if necessary)</small> </div>				APPLICANT: Craig M. Carpenter et al.			
				FILING DATE February 22, 2002		GROUP 1763	

U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	4,949,669	08/21/90	Ishii et al.			
	AB	6,309,161 B1	10/30/01	Hofmeister			
	AC	6,562,141 B2	05/13/03	Clarke			
	AD	6,5602,346 B1	08/05/03	Gochberg et al.			
	AE	6,638,672 B2	10/28/03	Deguchi			
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
	AJ	401273991A	11/01/89	Japan (Takeuchi))			Abstract	
	AK	406151558A	05/31/94	Japan (Honma et al.)			Abstract	
	AL	6342785	12/13/94	Japan (Wakabayashi))			Abstract	

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		
	AN		
	AO		

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.